Two-wavelength double heterodyne interferometry using a matched grating technique

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Two-wavelength double heterodyne interferometry is applied for topographic measurements on optically rough target surfaces. A two-wavelength He–Ne laser and a matched grating technique are used to improve system stability and to simplify heterodyne frequency generation.

I. Introduction

If an optically rough surface is illuminated by coherent light, the well-known speckle phenomenon occurs. Traditional interferometry on optically rough surfaces becomes difficult or impossible. To circumvent the speckle problem one can increase the wavelength (e.g., CO_2 laser) as described by Kwon *et al.*¹ Furthermore, a grazing incidence interferometer as shown by Murty and Shukla² can be used. Alternatively two wavelengths can be utilized simultaneously. The sensitivity is reduced to an effective wavelength λ_{ef} given by λ_{ef} $= \lambda_1 \lambda_2 / |\lambda_1 - \lambda_2|$ as shown by Wyant³ for a holographic setup and for real time application where an electrooptical crystal (BSO) was used to store the hologram instead of a photographic plate by Kuchel and Tiziani.⁴ Polhemus⁵ demonstrated contrast modulation of interference fringes by λ_{ef} generated with two wavelengths simultaneously. A scanning two-wavelength heterodyne speckle interferometer using a krypton laser was described by Fercher et al.⁶ where two phasemeters are needed to finally calculate the phase of the effective wavelength.

In this paper we describe a scanning double heterodyne technique (two laser wavelengths and heterodyne frequencies are used simultaneously) where a low frequency detection signal with a phase shift that corresponds to the effective wavelength is generated. A two-wavelength double heterodyne interferometer (DHI) setup consists basically of two independent heterodyne interferometers working at different wavelengths λ_1 and λ_2 and different heterodyne frequencies f_1 and f_2 . The phase of the beat frequency $f_1 - f_2$ depends on the effective wavelength λ_{ef} and can therefore be examined for distance evaluation as shown by Dandliker *et al.*⁷ Using two (highly stable) laser sources emitting different wavelengths, the heterodyne frequency shifts can easily be obtained by acoustooptical modulation (AOM) as shown in Fig. 1. The unshifted wavelengths are combined in a beam splitter (BS) and a monomode fiber (MMF) to generate an identical wavefront before being focused onto an optically rough specimen.

Only identical wavefronts of λ_1 and λ_2 will generate identical speckles in the entrance pupil of the imaging system and onto the detector. After passing a lens (L), a polarizing beam splitter (PBS) and a quarterwave plate the light is focused onto the specimen by a microscope objective (MO) as shown in Fig. 1. The quarterwave plate is passed twice and used to rotate the polarization by 90° to achieve reflection at the polarizing beam splitter. To match the polarizations of the reference and the target beam the polarization in the target beam is then rotated back by a halfwave plate (HWP) and combined in a beam splitter with the heterodyne frequency shifted beams. The interference signal is observed by a photodetector (Det). The beat frequency is generated by squaring the signals with a Schottky diode and then fed to a phase detector. The reference signal for the phase detector is generated in an additional interference arrangement to compensate for phase fluctuations of the two highly stable laser sources.

In the case of a multiline laser, to be discussed here, the wavelengths λ_1 and λ_2 are perfectly combined and have a good relative stability. In a conventional setup (similar to the one shown in Fig. 1, but with a multiline laser instead of two lasers) the laser radiation would be first divided into target and reference beams. The two wavelengths in the reference beam would be split (e.g.,

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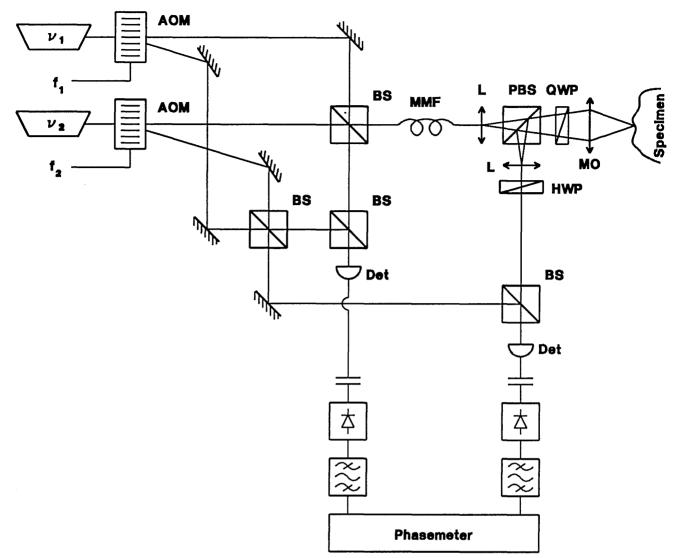


Fig. 1. Schematic double heterodyne interferometry setup.

by first-order diffraction of a grating), frequency shifted (AOM) by f_1 and f_2 , respectively, and recombined in a beam splitter. Such an approach however would be very sensitive to several sorts of disturbances.

In this paper a matched grating technique is described that minimizes disturbances and increases efficiency. Two examples (which are both using a twowavelength He–Ne laser) are given. The principle can be applied to all laser sources that emit two wavelengths simultaneously (e.g., argon laser) and where the wavelength differences are large enough to be separated by a diffraction grating.

II. Theory of Operation

Looking at the detector (shown in Fig. 1), the four complex amplitudes are given by

$$a_{1} = A_{1} \exp\left[i\left(2\pi v_{1}t - 4\pi \frac{v_{1}}{c}z\right)\right],$$
(1)

$$a_{2} = A_{2} \exp\left[i\left(2\pi v_{2}t - 4\pi \frac{v_{2}}{c}z\right)\right],$$
(2)

$$a_{3} = A_{3} \exp\left[i\left(2\pi(v_{1}+f_{1})t - 2\pi\frac{v_{1}+f_{1}}{c}l_{1}\right)\right],$$
(3)

$$a_4 = A_4 \exp\left[i\left(2\pi(v_2 + f_2)t - 2\pi\frac{v_2 + f_2}{c}l_2\right)\right].$$
 (4)

Equations (1) and (2) describe the target path and Eqs. (3) and (4) the reference path. The terms A_1, A_2 , A_3 , and A_4 indicate the individual amplitudes, v_1 and v_2 are the two laser frequencies, c is the speed of light, f_1 and f_2 are the heterodyne frequencies, and l_1 and l_2 are the individual reference path lengths. It is assumed that in l_1 and l_2 all possible interferometer pathlengths (not the target path z) are included. The intensity I at the detector is given by

$$I = |a_1 + a_3|^2 + |a_2 + a_4|^2$$

= $(a_1 + a_3)(a_1^* + a_3^*) + (a_2 + a_4)(a_2^* + a_4^*).$ (5)

The asterisk indicates complex conjugate terms. Inserting Eqs. (1), (2), (3), and (4) in Eq. (5) leads to

3140 APPLIED OPTICS / Vol. 30, No. 22 / 1 August 1991

$$I = A_1^2 + A_2^2 + A_3^2 + A_4^2 + 2A_1A_3 \cos\left(2\pi f_1 t + 4\pi \frac{v_1}{c} z - 2\pi \frac{v_1 + f_1}{c} l_1\right) + 2A_2A_4 \cos\left(2\pi f_2 t + 4\pi \frac{v_2}{c} z - 2\pi \frac{v_2 + f_2}{c} l_2\right).$$
(6)

The detector must be fast enough to detect the heterodyne frequencies f_1 and f_2 . The diopter term is removed from the detector signal by a capacitor. None of the terms in Eq. (6) is dependent on the effective wavelength λ_{ef} . It is obtained by squaring the detector signal. This is approximately achieved by applying it to a nonlinear element (e.g., diode). Cutting off the diopter intensity and squaring the terms given in Eq. (6) leads to

$$I^2 = 2A_1^2A_3^2 + 2A_2^2A_4^2$$

$$+ 2A_{1}^{2}A_{3}^{2}\cos\left(4\pi f_{1}t + 8\pi \frac{v_{1}}{c}z - 4\pi \frac{v_{1} + f_{1}}{c}l_{1}\right)$$

$$+ 2A_{2}^{2}A_{4}^{2}\cos\left(4\pi f_{2}t + 8\pi \frac{v_{2}}{c}z - 4\pi \frac{v_{2} + f_{2}}{c}l_{2}\right)$$

$$+ 4A_{1}A_{2}A_{3}A_{4}\cos\left(2\pi (f_{1} - f_{2})t + 4\pi \frac{v_{1} - v_{2}}{c}z - 2\pi \frac{v_{1} + f_{1}}{c}l_{1}\right)$$

$$+ 2\pi \frac{v_{2} + f_{2}}{c}l_{2}$$

$$4A_{1}A_{2}A_{3}A_{4}\cos\left(2\pi (f_{1} + f_{2})t + 4\pi \frac{v_{1} + v_{2}}{c}z - 2\pi \frac{v_{1} + f_{1}}{c}l_{1}\right)$$

$$- 2\pi \frac{v_{2} + f_{2}}{c}l_{2}$$
(7)

The phase of the lowest frequency term $(f_1 - f_2)$ in Eq. (7) now corresponds to the wanted effective wavelength $\lambda_{ef} = c/(v_1 - v_2)$. From the frequency spectrum in Eq. (7) this term is bandpass filtered. The result is a low frequency signal $(f_1 - f_2)$ with a phase that depends on the target distance z. The distance sensitivity is reduced to the effective wavelength.

III. Discussion of Error Sources

A. Inherent DHI Error Sources

An analysis of the low frequency term $(f_1 - f_2)$ in Eq. (7) shows that several components in the interferometer setup affect the accuracy of the phase (distance) measurement. Errors from fluctuations of the heterodyne frequencies f_1 and f_2 are small. These fluctuations alter the beat (detection) frequency, but do not affect the phase measurement because the heterodyne frequencies are by seven orders of magnitude lower than the laser frequencies. Nevertheless stabilization of f_1 and f_2 is required because the electronic signal processing needs bandpass filtering. If the heterodyne frequencies vary, phase errors are introduced by a bandpass filter as well as by a phasemeter.

The phase response ϕ in the relevant term of Eq. (7) is summarized to

$$\phi = 4\pi \left(\frac{v_1 - v_2}{c}\right) z - 2\pi \left(\frac{v_1 l_1 - v_2 l_2}{c}\right),\tag{8}$$

where the heterodyne frequencies f_1 and f_2 are omitted for reasons mentioned above. For a phase stability analysis the derivative of Eq. (8) is given by

$$\delta\phi = \frac{\partial\phi}{\partial\nu_1}\,\delta\nu_1 + \frac{\partial\phi}{\partial\nu_2}\,\delta\nu_2 + \frac{\partial\phi}{\partial l_1}\,\delta l_1 + \frac{\partial\phi}{\partial l_2}\,\delta l_2,$$

$$\delta\phi = \left(4\pi\,\frac{z}{c} - 2\pi\,\frac{l_1}{c}\right)\delta\nu_1 + \left(-4\pi\,\frac{z}{c} + 2\pi\,\frac{l_2}{c}\right)\delta\nu_2 - 2\pi\,\frac{\nu_1}{c}\,\delta l_1 + 2\pi\,\frac{\nu_2}{c}\,\delta l_2. \tag{9}$$

Equation (9) shows that, for accurate distance measurements, laser frequency fluctuations $\delta v_1 = \delta v_2 = \delta v$ as well as reference pathlength fluctuations $\delta l_1 = \delta l_2 = \delta l$ should be identical. Both requirements are difficult to achieve in a two laser setup (as shown in Fig. 1), but can be fulfilled with a matched grating technique combined with a single multiline laser that generates two wavelengths simultaneously.

A matched grating technique was developed to minimize the separation of the interferometer reference beams. Consequently, we found that if the polarization properties of both laser wavelengths are not identical, birefringence makes the requirement $\delta l_1 = \delta l_2$ very hard to fulfill. With this in mind Eq. (9) can be simplified to

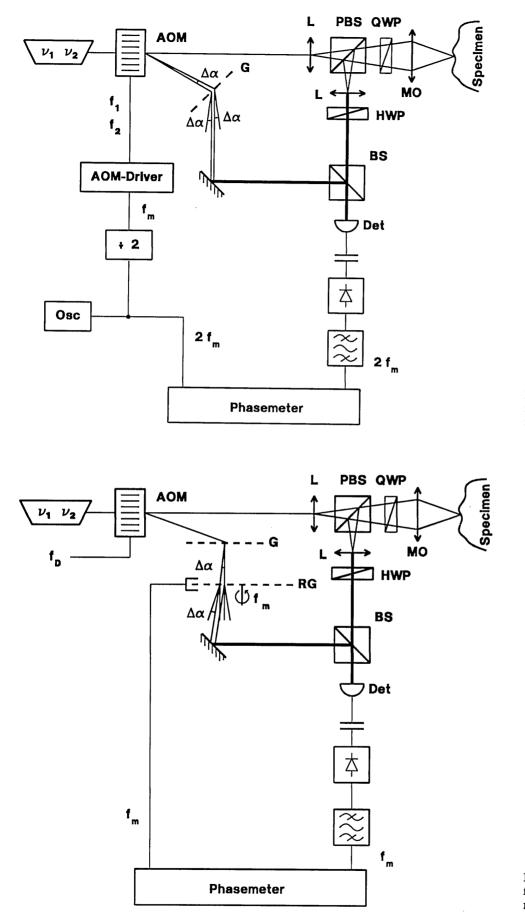
$$\delta\phi = \frac{2\pi}{c}\Delta l\delta v + \frac{2\pi}{\lambda_{\rm ef}}\delta l,\tag{10}$$

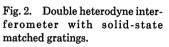
with the reference pathlengths difference $\Delta l = l_1 - l_2$ and the effective wavelength $\lambda_{\rm ef} = c/(v_1 - v_2)$. Our experimental arrangements (shown in Figs. 2 and 3) were almost phase insensitive ($\delta \phi < 0.1^{\circ}$) to laser frequency fluctuations δv because of a reference path difference Δl of <1 mm. Finally, the sensitivity to pathlength fluctuations in the reference beam δl (as well as in the target beam) is related to the effective wavelength $\lambda_{\rm ef}$.

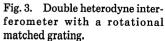
B. Error Sources from Rough Surfaces and Defocus

Although a DHI virtually works with an effective (long) wavelength λ_{ef} , the target is illuminated by two short laser wavelengths λ_1 and λ_2 that generate speckles on an optically rough surface. The influence of varying speckle intensities on phase error probabilities was theoretically and experimentally examined by Fercher *et al.*⁶ We found their results confirmed, but in our measurements the target distances were small and strong intensities occurred. By the choice of the integration time of the phase meter we were able to compensate for phase errors caused by temporary signal fading.

A second problem is the system's sensitivity to defocus. It is related to the laser wavelengths λ_1 and λ_2 , because interference of target and reference beams occurs before an effective wavelength λ_{ef} is (electronically) obtained. Spherical interference fringes occur on the photodetector and decrease the modulation contrast.







IV. Experiments

A. Double Heterodyne Interferometer with Solid State Matched Gratings

Figure 2 shows a multiwavelength He-Ne laser (Spindle & Hoyer) tuned to emit simultaneously and with equal intensity at 632.8 nm and 640.1 nm. This leads to an effective wavelength of $55.5 \,\mu$ m. As shown, only one AOM is required (compared to the setup shown in Fig. 1). The AOM is operated in suppressed carrier mode, where a modulation signal f_m is applied to the AOM driver, while the driver carried amplitude is turned to zero. This results in a multiplication of the driver carrier frequency f_d with the modulation frequency f_m leading to two side bands ($f_1 = f_d + f_m$ and $f_2 = f_d - f_m$) and suppressed carrier f_d . As a result, the AOM is operated at two frequencies, f_1 and f_2 , simultaneously. Two individual phase gratings are established in the AOM crystal leading to two first-order beams that leave the AOM under slightly different angles α_1 and α_2 . The diffraction efficiency (the energy distribution between the zero-order and the two first-orders) is optimized (Bragg angle) and adjusted with the driving power of the modulation signal f_m . In this way the frequencies of the two first-order diffracted beams are $v_1 + f_d - f_m$, $v_2 + f_d - f_m$ and $v_1 + f_d + f_m$, respectively. The small angle $\Delta \alpha = \alpha_1 - \alpha_2$ between the two first-order diffracted beams is approximately given by

$$\Delta \alpha = 2 \frac{\lambda}{n} f_m, \tag{11}$$

where $\lambda = \lambda_1$ or λ_2 , one of the He–Ne laser wavelengths (the spatial frequency of the AOM phase grating is far too low to separate the two laser wavelengths λ_1 and λ_2). The term v is the speed of sound in the AOM crystal.

In our new approach, we matched the angle $\Delta \alpha$ to the difference of the first-order diffraction angle (between λ_1 and λ_2) of a high spatial frequency grating (G).

The small angle Δ_{α} between the first-order diffraction of λ_1 and λ_2 , respectively, is approximately given by

$$\Delta \alpha = \lambda_2 g \sqrt{1 - (\lambda_1 g)^2} - \lambda_1 g \sqrt{1 - (\lambda_2 g)^2}, \qquad (12)$$

with the spatial frequency g of the grating. Matching two gratings accordingly, only beams with frequencies $v_2 + f_d - f_m$ and $v_1 + f_d + f_m$ become parallel. They are extracted to serve as reference for the interferometer as shown in Fig. 2. In this setup there is no (or hardly any) reference pathlength difference between l_1 and l_2 introduced as compared to the setup shown in Fig. 1. This makes the system almost insensitive to laser frequency variations. The shear of the reference beams shown in Fig. 2 is negligible because of a very small divergence angle $\Delta \alpha$. The modulation frequency is generated by an oscillator and divided by two before being applied to the AOM driver. Because of the two sidebands generated, the beat frequency is twice that of the modulation frequency f_m . Further downmixing of the signals is helpful, since highly accurate phase

meters are easier to obtain that work at low frequencies.

B. Double Heterodyne Interfeometer with a Rotational Matched Grating

In the setup shown in Fig. 3, the AOM is operated conventionally at driver frequency f_d . This shifts both He–Ne laser frequencies in the beam that leaves the AOM in Bragg diffraction. The two frequencies $v_1 + f_d$ and $v_2 + f_d$ are (first-order) diffracted a second time with a high spatial frequency (600 lp/mm) grating at angles α_1 and α_2 , respectively. The grating is calculated (and produced on photoresist) in a way that the diffraction angle difference $\Delta \alpha$ between $v_1 + f_d$ and $v_2 + f_d$ is the same as the first-order diffraction angle of a following (low spatial frequency) grating for the average He–Ne wavelength $\lambda = \lambda_1$ or λ_2 (considering λ_1 and λ_2 to be nearly the same for a low spatial frequency grating).

In this way the first-order diffraction of $v_1 + f_d$ and the zero-order of $v_2 + f_d$, as well as the zero-order of $v_1 + f_d$ f_d and the minus first-order of $v_2 + f_d$, become parallel as shown in Fig. 3. The second grating (RG) is a standard low cost angle encoder wheel (Hewlett Packard) with a spatial frequency of 7.2 lp/mm. It is continuously rotated by a motor. Because of rotation of the grating, the first-order diffracted light is frequency shifted by f_m while the zero-order light passes the grating unaffected. Selecting one pair of paralleled beams (as shown in Fig. 3) the frequencies of the beams are $v_1 + f_d + f_m = v_1 + f_1$ and $v_2 + f_d = v_2 + f_2$. They serve as reference for the interferometer. The beat frequency $f_m = f_1 - f_2$ is generated, after interference of reference and target beam, by rotation of the angle encoder. In our experiment the angle encoder wheel had 1000 lp/revolution and was rotated by 1200 rpm, therefore a heterodyne beat frequency of 20 KHz was found to be most appropriate. This frequency can be directly applied to an accurate low frequency phase meter (e.g., two channel lockin amplifier).

The reference for the lockin amplifier is directly taken from the angle encoder detector (square wave signal) output. Care must be taken, however, in the design of the encoder wheel bearing. During rotation different kinds of mechanical resonances can lead to phase fluctuations in the reference beam. Figure 4 shows the detector signal. The beat frequency $f_m = f_1 - f_2$ is shown in the upper part of the oscillogram and the squared and bandpass filtered signal in the lower part.

V. Results

The experimental results were obtained with a $10 \times$ microscope objective and an avalanche photodetector. The diffraction limited target spot was of the order of 3 μ m and the clear working distance to the target was 6.5 mm. The unoptimized measurement speed of about ten samples per second could be considerably increased due to availability of a strong target return signal. We calculated the SNR to be 45 dB in the

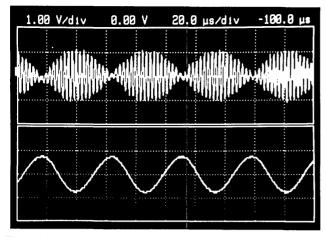


Fig. 4. (Upper part) superposition of heterodyne frequencies; (lower part) squared and band-pass filtered heterodyne beat signal.

presence of a bright speckle. The target was moved with a computer controlled stepper motor.

Figure 5 shows the phase response in a measurement where the target distance to a mirror was varied by 100 μ m. The unambiguous distance range ($\lambda_{ef}/2$) of 27.75 μ m as well as the good linearity are shown. Two successive topography measurements on a machined aluminum sample are shown in Fig. 6. On the sample, two steps of 5 and 10 μ m were milled into the surface. The topography is superimposed by a periodic height variation of the scanning table. It corresponds to one revolution (this is a scan of 0.5 mm) of the driving motor. In the first provisional experimental setup a resolution of the order of $0.5 \,\mu m$ was obtained. Some occasional height differences in both measurements can be explained by slow thermal expansion of the motor and mechanical vibration of the rotational grating. It is expected that the accuracy and the resolution can be increased considerably by the use of a solid state approach where an AOM is used instead of a rotational grating as mentioned above. These results will be presented in a later paper.

VI. Conclusions

Two-wavelength double heterodyne interferometry proved to be a powerful tool for sensitivity reduced interferometric measurements on smooth as well as on optically rough surfaces. We combined a dual wavelength He-Ne laser (632.8 and 640.1 nm) with a matched grating technique to prevent some inherent DHI problems and to simplify the setup. The unambiguous distance range of the DHI was 27.75 μ m and enabled measurements on machined aluminum samples. Intensity thresholding to reject phase (distance) data of signals with low amplitudes, as suggested by Fercher et al.,⁶ was not required in our experiments. The strong signals involved allowed us to compensate for signal fading and related phase errors by appropriate choice of phasemeter integration time while scanning. The matched grating principle could be used with a different optical projection system to build a

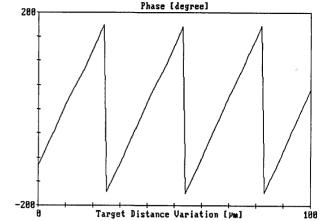


Fig. 5. Phase response from a target distance variation of $100 \,\mu\text{m}$.

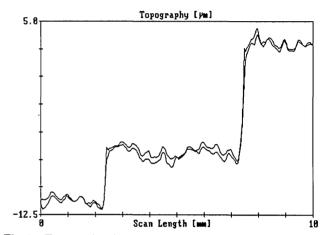


Fig. 6. Topography obtained from two successive line scans on a milled aluminum sample with step heights of 5 μ m and 10 μ m and superimposed by periodic height variations from the scan table.

highly accurate metrological instrument for distances up to several meters.

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